

Notice of References Cited	Application/Control No. 10/086,117	Applicant(s)/Patent Under Reexamination BOJKOV ET AL.	
	Examiner Monica Lewis	Art Unit 2822	Page 1 of 1

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	C	US-			
	D	US-			
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	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Peter Van Zant, Microchip Fabrication, 2000, McGraw-Hill, 115-129.
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.